SUPPLEMENTARY INFORMATION

Dopant driven tuning of hydrogen oxidation mechanism at the pore/nickel/zirconia

triple phase boundary

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HOR mechanism	Reaction step	Type of OCV correction	Y	Sc	Al	Ce	Ca	Y in bulk
O-migration	1-2 ^a	Any	1.26	1.27	0.87	1.36	1.26 ^b	1.80
On-boundary	4-5ª	Individual YSZ-based No	1.35 1.35 1.41	1.23° 1.22° 1.28°	1.29° 1.12° 1.18°	1.28 1.26 1.31	1.85 ^c 1.81 ^c 1.87 ^c	1.30 1.33 1.28
	7-8	Individual No	0.90 0.95	1.07 ^c 1.12 ^c	0.99° 0.88°	1.10 1.13	1.52° 1.54°	1.08 1.16
H-migration	4-5 ^a	Individual	1.35	1.17	1.29	1.22	1.85	1.30
	9-10 ^a	Individual	1.35	1.17	1.29	1.22	1.85	1.30

Table S1: Energy barriers (eV) for the three HOR mechanisms at 1000K after different types of OCV correction.

^a The step is rate-limiting for the corresponding HOR mechanism.

^b Migration of OH occurs from the nickel surface back to zirconia, which does not allow the HOR to be completed via the O-migration mechanism.

^c Dissociation of water molecule occurs at the TPB, which does not allow the HOR to be completed via the on-boundary mechanism.